



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 11, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG742512778

LABORATORY GROWN DIAMOND

OVAL MODIFIED BRILLIANT

8.04 x 5.95 x 4.95 mm

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

EXCELLENT

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

 LG742512778

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG742512778

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS

Thin To Medium (Faceted)

12%

45%

68%

83.2%

Pointed



Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: Exceptional



Structured Light Environment Representation

Moderate

High

Superior

Exceptional

Light Performance

Brightness

Fire

Contrast

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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Polish

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OVAL MODIFIED BRILLIANT

8.04 X 5.95 X 4.95 MM

Carat Weight

Color Grade

Clarity Grade

Table

Depth

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.70 CARAT

E

VS 1

83.2%

68%

Thin To Medium (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG742512778

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